



10-17-05

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 10/734,995  
Confirmation No. .... 2050  
Filing Date ..... December 12, 2003  
Inventor ..... Nishant Sinha  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2812  
Examiner ..... Jennifer M. Kennedy  
Attorney's Docket No. .... MI22-2464  
Customer No. .... 021567  
Title ..... Methods for Removal of Organic Materials (As Amended)

**RESPONSE TO AUGUST 23, 2005 OFFICE ACTION**

To: \ Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

From: Robert C. Hyta  
Wells St. John P.S.  
601 W. First Avenue, Suite 1300  
Spokane, WA 99201-3828  
Tel. 509-624-4276; Fax 509-838-3424

**AMENDMENTS**

### **Amendment to the Title**

Please amend the title as follows:

~~Methods for Forming Capacitor Structures; and Methods for Removal of Organic~~  
Materials